



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Baldwin et al.

Attorney Docket No.: 53757-5013

Serial No.: 10/812,409

Filed: March 29, 2004

For: System And Method For Performing :
Sputter Etching Using Independent :
Ion And Electron Sources And A :
Substrate Biased With An :
A-Symmetric Bi-Polar DC Pulse :
Signal :

**PETITION FOR TWO-MONTH EXTENSION
OF TIME AND FEE TRANSMITTAL**

Mail Stop Missing Parts
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Sir:

Applicant hereby petitions the Commissioner pursuant to 37 C.F.R. § 1.136(a) to extend the time for response to the Notice to File Missing Parts dated June 10, 2004, having a two-month shortened statutory period for response expiring August 10, 2004, by two months to and including October 10, 2004.

A check in the amount of \$210.00 to cover the filing and petition fees is transmitted herewith.

The Commissioner is hereby authorized to charge any deficiency in the enclosed amount or credit any overpayment to Deposit Account No. 50-0310.

Respectfully submitted,

Daniel H. Golub
Registration No. 33,701
MORGAN, LEWIS & BOCKIUS LLP
1701 Market Street
Philadelphia, PA 19103-2921
215.963.5055

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Dated: September 16, 2004